



Attorney's Docket No.: 004711/P1

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )  
 )  
Steven Verhaberbeke et al. )  
 )  
Application No: 09/891,849 ) Examiner: Markoff, Alexander  
 )  
Filed: June 25, 2001 ) Art Unit: 1792  
 )  
For: METHOD AND APPARATUS FOR )  
WAFER CLEANING )  
 )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL**

Dear Sir:

This is in response to the Final Office Action mailed March 21, 2008, Advisory Action mailed June 13, 2008, and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Preliminary Amendment and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

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